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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known				
Application Number	09/902,622	_		
Filing Date	July 12, 2001			
First Named Inventor	Jun KOYAMA, et al	_		
Group Art Unit	2672	_		
Examiner Name	Anthony J. Blackman			
Attorney Docket Number	0756-2339	_		

			***************************************	U.S. PATENT DOCUMENT	rs	
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)	Document	MM-DD-YYYY	
M		4,330,363		Biegesen et al	05/18/1982	
M		4,466,179		Kasten	08/21/1984	
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				FOREIGN PATENT DOC	UMENTS		
Examiner Initials*	Cite No.	Foreign Patent Document		Name of Patentee or	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant	
		Office	Kind Code ³ Number ⁴ (if known)	Applicant of Cited Document	MM-DD-YYYY	Figures Appear	Τ*
RU		JP	62-019855		02/05/1987		Full
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			OTHER PRIO	R ART – NON PATENT LITE	RATURE DOCUMENTS		
Examiner Initials	Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
se			M. Bonnel et al., IEEE Electron Dev. Lett., 14(12) (1993) 551 "TFTs with two step annealing process"				
1		I. Fu	jieda et al., IEDM, '	93 Proc., page 587, "Se	elf-referenced Polys-S	Si TFT amplifier"	
J		M. F	use et al., Sol. St. P	henom, 37-38 (1994) 50	65, "Performance of p	ooly-si TFTs"	

Examiner	4	Date	- (2 - ()
Signature	Mente.	Considered	7/27/06

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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